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Date : August 12, 2004  
TO : Director, Office of Patent Publication  
FROM : Office of the Deputy Commissioner  
for Patent Examination Policy  
SUBJECT : Withdrawal from Issue of **Application No. 09/935,585**

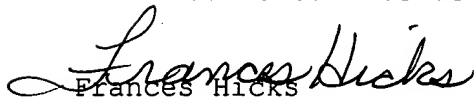
Applicant(s) : Haruo Shindo et al  
Application No. : 09/935,585  
Filed : August 24, 2001

The above-identified application has been assigned Patent No. 6,777,962 and an issue date of August 17, 2004.

It is hereby directed that this application be withdrawn from issue at the request of the applicant. Do not refund the issue fee.

The following erratum should be published in the Official Gazette if the above-identified application is published in the OG of August 17, 2004:

**"All reference to Patent No. 6,777,962 to Haruo Shindo et al of Japan for METHOD OF MEASURING ELECTRON ENERGY DISTRIBUTION IN PLASMA REGION AND APPARATUS FOR MEASURING THE SAME appearing in the Official Gazette of August 17, 2004 should be deleted since no patent was granted."**



Frances Hicks  
Petitions Examiner  
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